Appl. No. 10/524,981 Docket No. NL03 0866 US Amdt. dated April 5, 2007 Response to Office Action dated February 8, 2007

## REMARKS/ARGUMENTS

Claims 1-24 are pending in the application.

In response to the Restriction Requirement, Applicant elects Group II, drawn to a method of making a semiconductor ferroelectric device.

Please cancel claims 1-15 without prejudice. Claim 16 has been amended to better recite the inventive steps of making a ferroelectric device.

The Commissioner is hereby requested and authorized pursuant to 37 CFR §1.136(a)(3), to treat any concurrent or future reply in this application requiring a petition for extension of time for its timely submission, as incorporating a petition for extension of time for the appropriate length of time. Please charge any additional fees which may now or in the future be required in this application, including extension of time fees, but excluding the issue fee unless explicitly requested to do so, and credit any overpayment, to Deposit Account No. 50-4019.

Respectfully submitted.

Date: 05-APR-2007 By /Peter Zawilski/

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